

241154US-0

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
YUUKI TAUCHI ET AL. : ATTN: APPLICATION DIVISION
SERIAL NO: NEW NON-PROVISIONAL
APPLICATION :
FILED: HERewith :
FOR: Ag BASE ALLOY THIN FILM AND
SPUTTERING TARGET FOR FORMING
Ag BASE ALLOY THIN FILM

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the application identified above as follows.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 19 of this paper.